



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Michael E. Fossey et al. Art Unit : 2877
 Serial No. : 10/601,698 Examiner : Unknown
 Filed : June 24, 2003
 Title : WAFER INSPECTION SYSTEM FOR DISTINGUISHING PITS AND PARTICLES

Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

NOTICE OF RELATED LITIGATION

In accordance with MPEP 2001.06(c), Applicants call attention to a pending litigation that is related to the subject matter of this application. In a complaint filed October 11, 2000, and an amended complaint filed January 30, 2002, ADE Corporation, the assignee of this application, asserted infringement of the following U.S. patents assigned to them: 6,118,525 and 6,292,259. U.S. Patent Nos. 6,118,525 and 6,292,259 resulted from applications of which this application is a continuation.

Applicants intend to file an information disclosure statement including information from this litigation shortly.

This statement is being filed before the receipt of a first Office action on the merits.
 Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: 2/2/04


 John F. Hayden
 Reg. No. 37,640

Fish & Richardson P.C.
 1425 K Street, N.W.
 11th Floor
 Washington, DC 20005-3500
 Telephone: (202) 783-5070
 Facsimile: (202) 783-2331